| L Number | Hits | Search Text | DB | Time stamp |
|------------|------------|---|-------------|---------------------|
| - | 48003 | thin adj film adj transistor | USPAT; | 2004/06/22 12:46 |
| } | l | • • | US-PGPUB; . | |
| 1 | l | | EPO; JPO; | |
| | l | | DERWENT; | |
| • | 1 | | IBM_TDB | |
| - | 198 | thin adj film adj transistor adj array adj panel | USPAT; | 2004/06/22 12:47 |
| | 1 | | US-PGPUB; | |
| | 1 | , | EPO; JPO; | |
| | 1 | · | DERWENT; | |
| 1 | | | IBM_TDB | |
| - | 155 | (thin adj film adj transistor adj array adj panel) and (pixel adj | USPAT; | 2004/06/22 12:48 |
| İ | | electrode) | US-PGPUB: | |
| | | , | EPO: JPO: | |
| | | | DERWENT; | |
| | | | IBM_TDB | |
| - | 92 | (thin adj film adj transistor adj array adj panel) and ((pixel adj | USPAT; | 2004/06/22 12:49 |
| | | electrode) with passiv\$6) | US-PGPUB; | |
| Į. | | | EPO; JPO; | |
| | l | | DERWENT: | |
| 1 | | | IBM_TDB | |
| - | 87 | ((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 12:51 |
| 1 | I | adj electrode) with passiv\$6)) and ((drain adj electrode) same | US-PGPUB; | |
| 1 | | (contact adj hole)) | EPO; JPO; | |
| | | (| DERWENT; | |
| | | | IBM_TDB | |
| - | 88 | ((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 12:51 |
| | 1 | adj electrode) with passiv\$6)) and (drain adj electrode) and | US-PGPUB; | 200 1100/22 12:01 |
| 1 | | (contact adj hole) | EPO; JPO; | |
| | | , , , | DERWENT; | |
| | | | IBM_TDB | |
| _ | 88 | (((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 12:52 |
| | | adj electrode) with passiv\$6)) and (drain adj electrode) and | US-PGPUB; | |
| 1 | | (contact adj hole)) and passiv\$6 | EPO; JPO; | |
| | | | DERWENT; | |
| | | • | IBM_TDB | |
| - | 78 | ((((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 13:55 |
| | | adj electrode) with passiv\$6)) and (drain adj electrode) and | US-PGPUB; | |
| | | (contact adj hole)) and passiv\$6) and (ohmic adj contact) | EPO; JPO; | |
| | | | DERWENT; | • |
| | | | IBM_TDB | |
| - | 3 | (((((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 12:59 |
| İ | | adj electrode) with passiv\$6)) and (drain adj electrode) and | US-PGPUB; | • |
| 1 | | (contact adj hole)) and passiv\$6) and (ohmic adj contact)) | EPO; JPO; | |
|] | | and ((polysilicon with insulating) same doped) | DERWENT; | |
| [| _ | | IBM_TDB | |
| - | 0 | (((((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 13:57 |
| | | adj electrode) with passiv\$6)) and (drain adj electrode) and | US-PGPUB; | |
| [| | (contact adj hole)) and passiv\$6) and (ohmic adj contact)) | EPO; JPO; | |
| . | | and (photoresist\$4 same pattern\$4 same impurity) | DERWENT; | |
| 1 | | | IBM_TDB | |
| j - | 57 | (((((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 15:02 |
| | | adj electrode) with passiv\$6)) and (drain adj electrode) and | US-PGPUB; | |
| | | (contact adj hole)) and passiv\$6) and (ohmic adj contact)) | EPO; JPO; | • |
| | | and (photoresist\$4 same pattern\$4) | DERWENT; | |
| | د - | | IBM_TDB | 000 (100 (00) = 55 |
| - | 57 | ((((((thin adj film adj transistor adj array adj panel) and ((pixel | USPAT; | 2004/06/22 15:02 |
| | | adj electrode) with passiv\$6)) and (drain adj electrode) and | US-PGPUB; | |
| [| | (contact adj hole)) and passiv\$6) and (ohmic adj contact)) | EPO; JPO; | |
| | | and (photoresist\$4 same pattern\$4)) and impurity | DERWENT; | |
| L | | | IBM_TDB | |